

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICATION NO.: 10/664,247

APPLICANT(S): Stewart et al.

FILING DATE: 09/17/2003

TITLE: Photolithography Mask Repair

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Pursuant to the guidelines for Information Disclosure Statements, 37 C.F.R. §§ 1.97-1.98, attached hereto is form PTO/SB/08A with references listed for consideration by the Office.

In accordance with 37 C.F.R. §§ 1.97(g)-(h), the filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made or an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

As the statement of relevance of the foreign language reference, applicants enclose a copy of a European Search Report citing the disclosed references.

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**CERTIFICATE OF MAILING UNDER 37 C.F.R. 1.8**

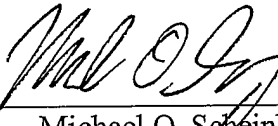
I hereby certify that this correspondence is being transmitted to the PTO via the Electronic Filing System:

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This Information Disclosure Statement is being filed after the mailing of a first Office action and before the mailing date of any final action under 37 C.F.R. § 1.113, a Notice of Allowance under 37 C.F.R. § 1.311, or an action that otherwise closes prosecution in the application, and is accompanied by the fee set forth in 37 C.F.R. § 1.17 (p).

Respectfully submitted,

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